## Single and multilayer graphene and MoS<sub>2</sub> thin-film transistors: 1/f noise and gas sensing

R. Samnakay, C. Jiang, S. L. Rumyantsev, A. A. Balandin, R. Potyrailo, and M. Shur

Materials Science and Engineering Program and Dept. of Electrical Engineering, Univ. of California – Riverside, Riverside, CA 92521; GE Global Research, Niskayuna, NY 12309; and ESCE Dept., Rensselaer Polytechnic Institute, Troy, NY 12180, USA

We report on the transport and low-frequency noise measurements of the back-gated graphene and  $MoS_2$  thin-film transistors with "thin" (1–3 atomic layer) and "thick" (7–18 atomic layer) channels. This comparison reveals that the noise mechanisms in graphene and thick  $MoS_2$  are quite different, with the McWhorter model (involving tunneling from trap states in the barrier dielectric layer) applicable to 1/f noise only in the thick  $MoS_2$  devices [1]. The normalized spectral density of the low-frequency 1/f noise in the "thick"  $MoS_2$  transistors is of the same level as in graphene. The  $MoS_2$  transistors with the atomically thin channels have substantially higher noise levels. The McWhorter model allows estimating the trap density responsible for the low-frequency noise in the thick  $MoS_2$  transistors (~  $10^{18}$  cm<sup>-3</sup>eV<sup>-1</sup>).

These devices are superior candidates for sensing applications due to the high surface-to-volume ratio and tunability by the gate bias. Both graphene [2] and  $MoS_2$  [3] have been used for the *selective* detection of ethanol, acetonitrile, toluene, chloroform, and methanol vapors. Gas exposure causes dramatic changes in the device current-voltage characteristics, especially for the  $MoS_2$  devices, allowing us to demonstrate a gas-gated transistor. In addition to these changes in the device current-voltage characteristics, the time dependent response and/or changes in the 1/f spectra under the gas exposure provide unique signatures for the selective gas detection.

- S. L. Rumyantsev, C. Jiang, R. Samnakay, M. S. Shur, and A. A. Balandin, *IEEE Electron Dev. Lett.* 36, 517 (2015).
- S. L. Rumyantsev, G. Liu, M. S. Shur, R. A. Potyrailo and A. A. Balandin, *Nano Lett.* 12, 2294 (2012).
- R. Samnakay, C. Jiang, S. L. Rumyantsev, M.S. Shur and A. A. Balandin, *Appl. Phys. Lett.* 106, 023115 (2015).